

Supplementary Material

Influence of Deposition Method on the Structural and Optical Properties of Ge₂Sb₂Te₅

Iosif-Daniel Simandan ¹, Florinel Sava ¹, Angel-Theodor Buruiana ¹, Aurelian-Catalin Galca ¹, Nicu Becherescu ², Ion Burducea ³, Claudia Mihai ¹ and Alin Velea ^{1,*}

¹ National Institute of Materials Physics, Atomistilor 405A, 077125 Magurele, Romania; simandan@infim.ro (I.-D.S.); fsava@infim.ro (F.S.); angel.buruiana@infim.ro (A.-T.B.); ac_galca@infim.ro (A.-C.G.); claudia.mihai@infim.ro (C.M.)

² Apel Laser Ltd., Vanatorilor 25, 077135 Mogosoaia, Romania; becherescu@gmail.com

³ Horia Hulubei National Institute of Physics & Nuclear Engineering, 077125 Magurele, Romania; bion@nipne.ro

* Correspondence: alin.velea@infim.ro



Figure S1. The custom built MSPLD deposition system.

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